

# **INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)

Docket Number (Optional)

**NEC A433**

Application Number

Applicant(s)

**TOUNAI**

Filing Date

**March 31, 2004**

Group Art Unit

## **U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## **FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/E.P./		2000-214577	04.08.2000	JAPAN (w/Abstract)	G03F	1/08		✓
/E.P./		11-338904	10.12.1999	JAPAN (w/Abstract)	G06F	17/50		✓
/E.P./		11-096200	09.04.1999	JAPAN (w/Abstract)	G06F	17/50		✓
/E.P./		2000-294650	20.10.2000	JAPAN (w/Abstract)	H01L	21/82		✓

## **OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER	/Edward Park/	DATE CONSIDERED	06/21/2007
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and no considered. Include copy of this form with next communication to applicant.